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(71) Applicant (for all designated States except US): SAM-SUNG ELECTRONICS CO. LTD. [KR/KR]; 416, Maetan-dong, Paldal-ku, 442-370 Suwon-city, Kyungki-do (KR).

(72) Inventors; and

(75) Inventors/Applicants (for US only): PARK, Hong-Sick [KR/KR]; Shinmyung Apt. 1-1001, 384-2, Kugal-ri, Kiheung-eup, 449-900 Yongin-city, Kyungki-do (KR). KANG, Sung-Chul [KR/KR]; Hyundai Sungwoo 2-cha Apt. 164-1001, Sanghyun-ri, Suji-eup, 449-843 Yongin-city, Kyungki-do (KR). CHO, Hong-Je [KR/KR]; Jookong 1-cha Apt. 107-304, Youngtong-dong, Paldal-ku, 442-470 Suwon-city, Kyungki-do (KR). PARK, An-Na [KR/KR]; 1062-14, Kwangan 3-dong, Suyoung-ku, 613-810 Busan-city (KR). PARK, Pong-Ok [KR/KR]; 728-146, Bongcheon 1-dong, kwanak-ku, 151-831 Seoul

(KR). **JEONG**, Chang-Oh [KR/KR]; Byeksan Apt. 111-1001, Mangpo-dong, Paldal-ku, 442-707 Suwon-city, Kyungki-do (KR).

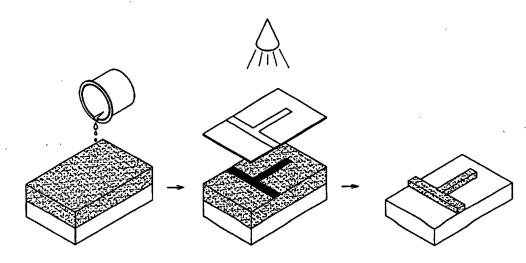
- (74) Agent: YOU ME PATENT & LAW FIRM; Teheran Bldg., 825-33, Yoksam-dong, Kangnam-ku, 135-080 Seoul (KR).
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(54) Title: A METHOD OF FORMING A METAL PATTERN AND A METHOD OF FABRICATING TFT ARRAY PANEL BY USING THE SAME



(57) Abstract: With a metal pattern formation process and a method of manufacturing a thin film transistor array panel using the metal pattern formation process, an organometallic layer is formed by coating an organometallic complex containing metal. The organometallic layer is exposed to light through a photo mask, and developed to form a metal pattern.

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